

Electronic Patent Application Fee Transmittal**Application Number:**

08893917

Filing Date:

11-Jul-1997

Title of Invention:REMOTE PLASMA CLEANING SOURCE HAVING REDUCED REACTIVITY WITH A
SUBSTRATE PROCESSING CHAMBER**First Named Inventor/Applicant Name:**

KARL A. LITTAU

Filer:

William Leland Shaffer/Sharyl Brown

Attorney Docket Number:

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Utility under 35 USC 111(a) Filing Fees**Description****Fee Code****Quantity****Amount****Sub-Total in
USD(\$)****Basic Filing:****Pages:****Claims:****Miscellaneous-Filing:****Petition:****Patent-Appeals-and-Interference:**

Filing a brief in support of an appeal

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540

540

Post-Allowance-and-Post-Issuance:**Extension-of-Time:**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				540